

## CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION UNDER 37 CFR 1.8(a)

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Date: January 20, 2003  
Paul R. Steffes

1/24/03

Case No: F0541

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Bin Yu, et al.

Serial No.: 09/900,400 Examiner: Kiesha L. Rose

Filing Date: July 5, 2001 Art Unit: 2822

Title: **SOI MOSFET WITH ASYMMETRICAL SOURCE/BODY AND  
DRAIN/BODY JUNCTIONS** FAX RECEIVED

JAN 20 2003

Commissioner for Patents  
United States Patent and Trademark Office  
Washington, D.C. 20231

TECHNOLOGY CENTER 2800

RESPONSE TO OFFICE ACTION DATED SEPTEMBER 21, 2002

Sir:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following amendments and remarks.

AmendmentsIn the Claims:

Please amend claim 1 as follows:

*sub b1  
A1*

1. (Amended) A semiconductor-on-insulator (SOI) device comprising:  
a semiconductor substrate layer;  
an insulator layer disposed on the substrate layer;